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Hashizume et al.

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[54] **INK JET RECORDING HEAD HAVING
REDUCED STRESS CONCENTRATION
NEAR THE BOUNDARIES OF PRESSURE
GENERATING CHAMBERS**

3-65350 3/1991 Japan 347/68
5-504740 7/1993 Japan B41J 2/16
5-286131 11/1993 Japan B41J 2/045

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[51] Int. Cl.⁷ **B41J 2/045**

[52] U.S. Cl. **347/70**

[58] Field of Search 347/68, 70, 71,
347/72

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[57] ABSTRACT

An ink-jet recording head comprising: an elastic sheet providing pressure generating chambers; nozzle orifices, each communicating with the pressure generating chamber; piezoelectric vibrators formed on the elastic sheet, each of the piezoelectric vibrators having, a lower electrode formed on the elastic sheet, a piezoelectric layer formed on the lower electrode, and an upper electrode formed on the piezoelectric layer such that the upper electrode faces the respective pressure generating chamber, wherein the upper electrodes of the piezoelectric vibrators are positioned independently of each other; an electrical insulator layer having windows, wherein the electrical insulator layer covers the upper electrodes; and a conductor pattern connecting with the upper electrodes via the windows of the electrical insulator layer.

12 Claims, 7 Drawing Sheets